## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Louis N. Koppel et al.

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For: CALIBRATION AND ALIGNMENT

OF X-RAY REFLECTOMETRIC

**SYSTEMS** 

Group Art Unit: 2882

Examiner: I. Kiknadze

CHANGE OF ATTORNEY OR AGENT'S ADDRESS IN APPLICATION (37 CFR 1.8(a))

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CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope, addressed to: Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450 on June 4, 2004.

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Dated: 06/04/2004

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